

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Serial No.: 09/781,616 Conf. No.: 9505 JAN 18 2005
Filing Date: 02/12/2001 Art Unit: 2141
Applicant: Iwao Hatanaka Examiner: Lien, Tan
Title: METHOD AND SYSTEM FOR Docket No.: CHA9-99-015 (IMBC-0105)
AUTOMATED SESSION RESOURCE CLEAN-UP IN
A DISTRIBUTED CLIENT-SERVER ENVIRONMENT

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 703-872-9306

Transmitted herewith is: After-Final Amendment in 9 pages
in the above identified application.

- ☒ No additional fee is required.
- ☒ The Commissioner is hereby authorized to charge and credit Deposit Account No. 09-0469 (IBM) as described below.
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.



Michael F. Hoffman, Reg. No. 40, 019

DATE: January 18, 2005

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below.

Darci L. DeLisle
(Person transmitting this correspondence)



Signature

January 18, 2005

Date

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**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2822**

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**Title: METHOD AND SYSTEM FOR AUTOMATED SESSION RESOURCE
CLEAN-UP IN A DISTRIBUTED CLIENT-SERVER ENVIRONMENT**

**Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

AFTER-FINAL RESPONSE

Dear Sir:

I. Introductory Comments

In response to the final Office Action dated November 23, 2004, please reconsider the pending patent application in view of the following remarks.

09/781,616

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